

# Description

The new Ultra Clean Water Filtration Skid features the latest technology for ultrapure water cleanliness, using a newly developed ultrafiltration (UF) membrane that is dual-rated at 2 nm and 4 kD.

UF is the state of the art final filtration step prior to the final utilization of ultrapure water in semiconductor manufacturing. It is used to remove traces of

- Nanoparticles
- Macromolecules
- Colloidal silicates
- out of ultrapure water.

Hollow fiber membranes bundled in UF module housings divide the incoming ultrapure water into ultra clean permeate and contamination containing reject. Controlled back-diffusion of accumulated particles prevents contamination of the membrane. The reject – typically 5% of the permeate flow – discharges the collected contaminations from the UF modules. The reject flow will be cleaned up in a polisher.

The Ultra Clean Water Filtration Skid is used for today's most demanding ultra-high purity water systems in sub fab level or at the point of use.

# A Key Tool for UPW Supply in the Semiconductor Industry

Up to four UF modules are combined in a closed micro environment. They facilitate up to 50 m<sup>3</sup>/h permeate flow. Skids can be combined to provide higher flow capacity.

A purge flow of filtered clean dry air (CDA) prior to and during maintenance creates a clean environment surrounding the UF modules and reduces contamination of interfaces and piping/module connections.

Water reject is treated by a polishing unit that increases recovery rate up to 100%.

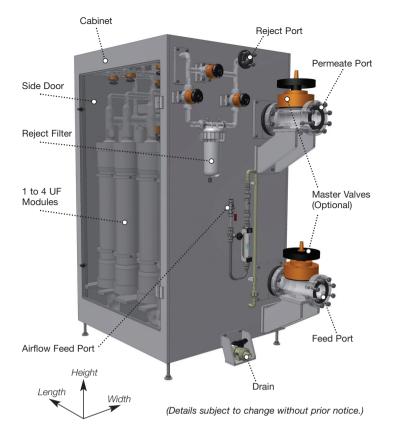
\* Microza is a trademark of Asahi Kasei Chemical Corporation

# Ultra Clean Water Filtration Skid



## **Designed to Meet the Highest Demands**

- Superior retention of nanoparticles, macro-molecular contamination and colloidal silicates
- Up to 100% recovery rate
- Uses high performance Pall Microza UF modules
- Preventive maintenance based on *in situ* module integrity tests using Palltronic<sup>®</sup> analyzers
- Compact "all in one" cabinet provides smallest footprint
- PVDF HP piping for highest purity
- Air purging facilitates module exchange and maintenance operations under micro environment
- Recording, visualization and digital monitoring of pressure signals by an electronic data manager enables easy system integration
- "Plug & play" approach minimizes time and cost for installation and commissioning
- · Seismic brackets



#### **Design Parameters**

	Unit	Value
Maximum operating pressure	barg	9
Maximum operating temperature*	°C	up to 80
Design Permeate flow rate	m³/h	up to 50
Design airflow	Nm³/h	up to 58
Material for water piping system		PVDF HP
Number of UF modules		1 to 4
Suitable UF module series	Pall Microza OAT-603	6 or OLT-6036

\* 90 °C for short term sanitization





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### **Specifications**

#### Dimensions (Length x Width x Height)

Base Unit: 1,250 x 1,100 x 2,174 mm Base Unit + Valves: 1,618 x 1,100 x 2,174 mm

#### Space Requirements

#### (Length x Width x Height, approximate)

 Base Unit:
 2,000 x 2,300 x 2,500 mm

 Base Unit + Valves:
 2,370 x 2,300 x 2,500 mm

#### **Net Weight**

380 kg (without disposable filters and UF Modules, approximate)

#### **Main Connections**

Feed and Permeate: DN100 or 4" Reject: DN25 or 1"

#### **Options**

Master valves DN100 or 4" for feed and permeate Further options on demand

#### Utilities

- Power supply for data logger: 110-230 V AC, 1 phase 50 or 60 Hz.
- Air supply:
   0.6 0.8 MPa (87 116 psig);
   < 60 Nm<sup>3</sup>/h (temporarily);
   dry, filtered, oil-free, ambient temperature
- 24 V interface



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